

# 5th Conference on Integrated Optics - Sensors, Sensing Structures and Methods IOS 2011

Conference web-site: <http://ios.polsl.pl/>

Conference venue: Szczyrk, Beskidy Mountains in Poland, 28th February to 4th March 2011

The Optoelectronic Department at the Silesian University of Technology in Gliwice, Poland was organising the scientific international conference, which took place on 28th February to 5th March 2011, on: Integrated Optics - Sensors, Sensing Structures and Methods, IOS'2011.

The Conference will be organized in Szczyrk, in Beskidy Mountains in Poland, in real winter scenery. The co-Organizers of the Conference are the Committee of Electronics and Telecommunication of Polish Academy of Sciences, Photonic Society of Poland and Upper Silesian Division of the Polish Acoustical Society.

Honorary Patronage on the Conference is taken by Professor Wiesław Woliński - Real Member of Polish Academy of Sciences and Professor Andrzej Karbownik - Rector of The Silesian University of Technology.

The main goal of the Conference is to exchange knowledge in the scope of practical applications of integrated optics. The aim of the Conference is presentation of experiences in the field of technology and theoretical analysis of optoelectronic sensors and the practical applications of sensing structures and the systems as well as new methods in the field of metrology.

The Conference contributes to amplify relations between scientific groups and to enable the intensification of common cooperation for the development of practical optoelectronics.